



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Shunpei YAMAZAKI et al.)
Serial No. 09/334,646)
Filed: June 17, 1999)
For: SEMICONDUCTOR DEVICE AND)
FABRICATION METHOD)
THEREOF)

) Art Unit: 2811

) Examiner: S. Hu

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
The United States Postal Service with sufficient postage as First
Class Mail in an envelope addressed to: Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450, on June 11, 2003.

Atsushi M. Otani

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 11, 2003, please amend the
above-identified application as follows:

IN THE CLAIMS:

Please amend the claims as follows:

J1 106. (Amended) The display device according to claim 104, wherein the laser
annealing is performed to crystallize an amorphous semiconductor layer in order to
obtain a crystalline semiconductor layer.

J2 109. (Amended) The display device according to claim 107, wherein the laser
annealing is performed to crystallize an amorphous semiconductor layer in order to
obtain a crystalline semiconductor layer.

37# / Amdt J
6/28/03
TECHNICAL DIVISION
RECEIVED
USPTO
Atsushi M. Otani